

Microfluidic chips are used to separate particles of differing sizes. A piezoelectric transducer is attached to the silicon chip and has a thin wall 300 µm from one side. As a sample passes through the chip, the larger particles are concentrated at the low pressure node of the standing wave while the sample. When the chips are fabricated, there are small variations in the dimensions of the wall. This leads to each chip acting slightly differently in laboratory tests. The goal of these simulations is to determine the effect of the wall shapes over a range of 10µm around the actual dimensions of 13µm and 6µm measured from a sample chip. The wall dimensions are taken as the lengths of the wall dimensions increases, focusing frequency increases and focusing position moves farther from the wall.

- standing wave
- particles move toward low pressure nodes





FEA Investigation of Microfabricated Structural Variation in Acoustofluidic Devices

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